

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicants: KIM, Hyun-Jae and KANG, Myung-Koo
Assignee: SAMSUNG ELECTRONICS CO., LTD.
Title: METHOD OF POLYCRYSTALLIZATION, METHOD OF
MANUFACTURING POLYSILICON THIN FILM TRANSISTOR,
AND LASER IRRADIATION DEVICE THEREFOR
Application No.: 10/532,459 Filing Date: 11/02/2005
Examiner: BOOTH, Richard A. Group Art Unit: 2812
Docket No.: AB-1432 US Confirmation No.: 1783

San Jose, California
June 4, 2007

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR § 1.97(b)

Dear Sir:

Pursuant to 37 CFR § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying Form PTO-1449 are called to the attention of the Examiner for the above patent application. Copies of these documents are enclosed with the exception of any U.S. Patents and U.S. Patent Publications. The documents were first cited in an Office Action dated March 30, 2007 by the Chinese Patent Office in corresponding Chinese Patent Application No. 200380101946.7.

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No fee is believed to be required. If a fee is required for this Information Disclosure Statement, please charge the fee to Deposit Account No. 50-2257. This paper is being submitted in duplicate.

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Respectfully submitted,



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U.S. Department of Commerce, Patent and Trademark Office				Atty. Docket No.		Application No.	
				AB-1432 US		10/532,459	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)				Applicant(s)			
				KIM, Hyun-Jae and KANG, Myung-Koo			
				Filing Date		Group	
				11/02/2005		2812	

U.S. Patent Documents							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

Foreign Patent Documents							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	AL	CN 1304548 A	07/18/2001	China				X
	AM							
	AN							
	AO							
	AP							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)		
	AQ	English Language Abstract, Publication No. CN 1304548, 07/18/2001, 1 p.
	AR	
	AS	

Examiner	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.